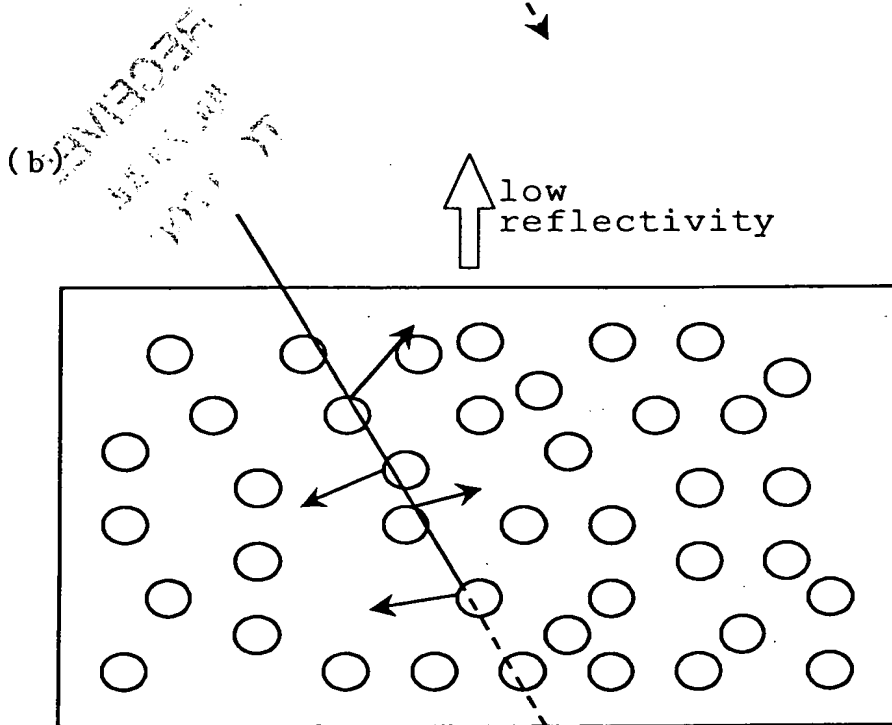
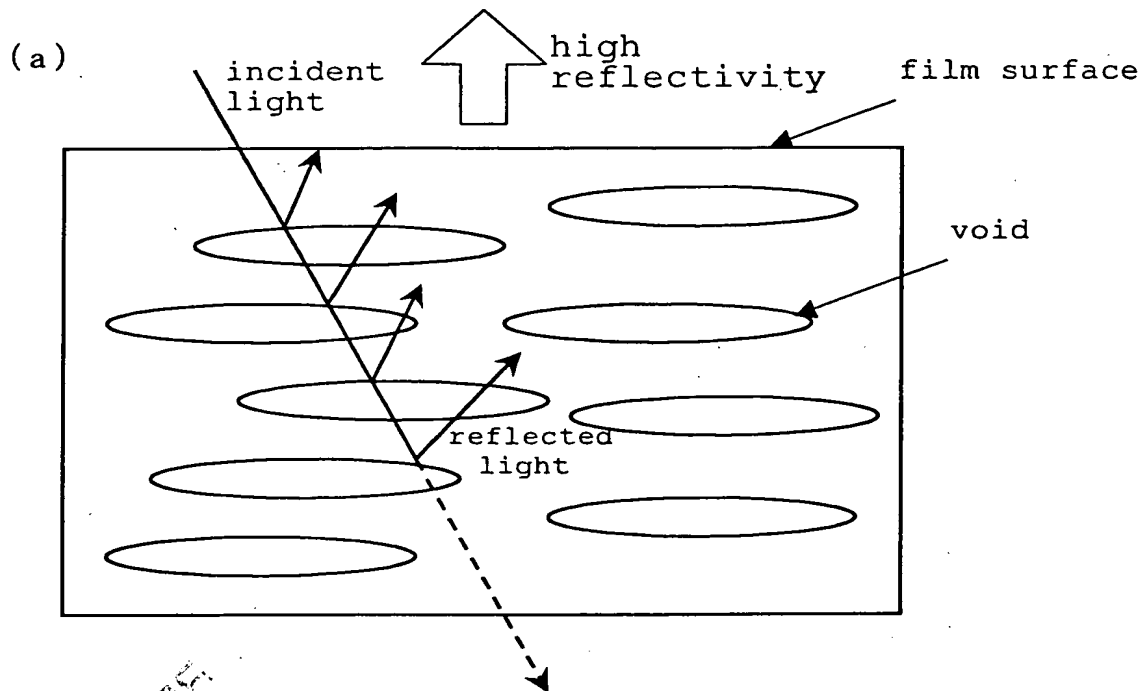
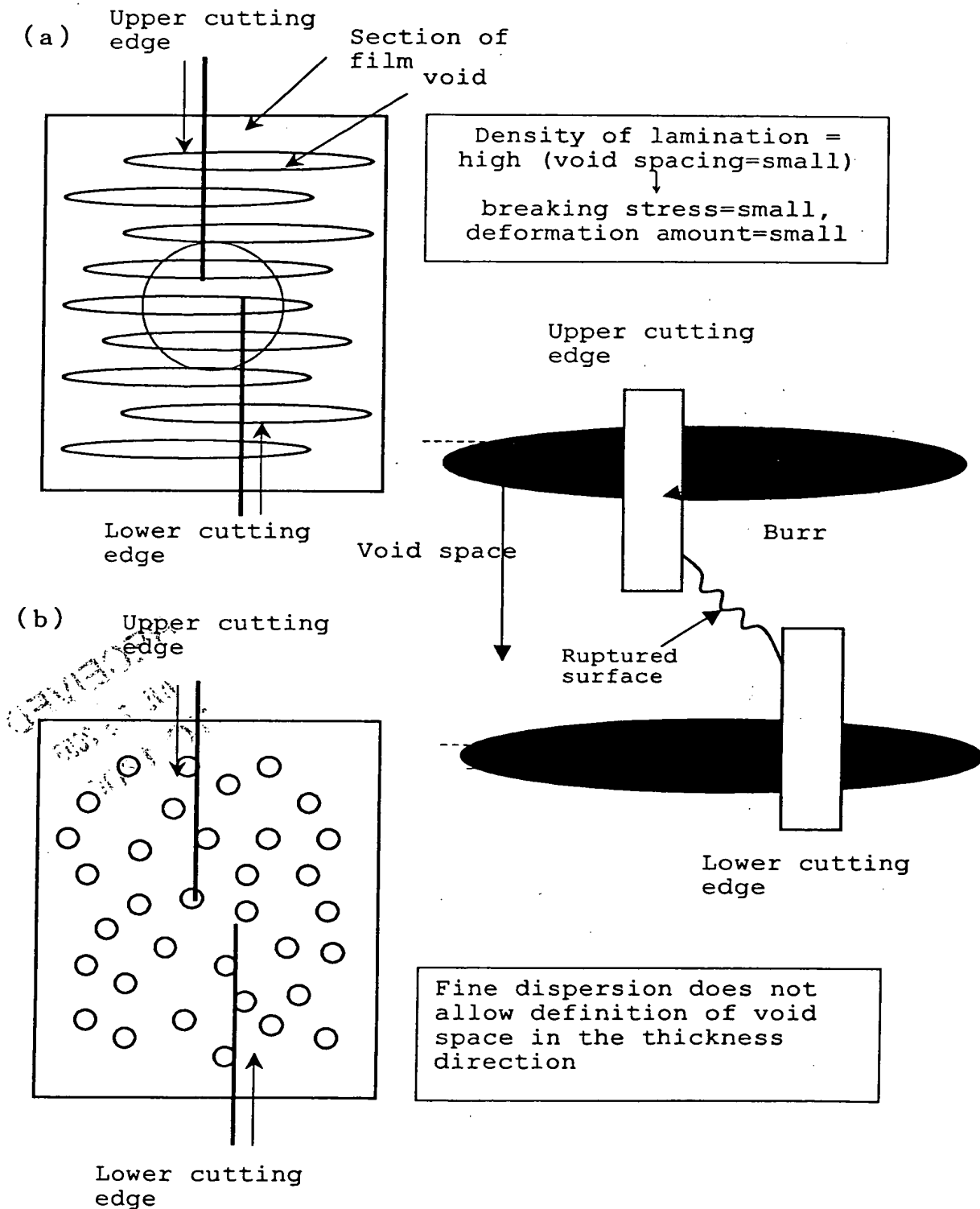


Reference Fig. 1 (mechanism of improved reflectivity)



Characteristic of invention:  
many voids (interface)  
parallel to the surface

Reference Fig. 2 (mechanism of improved applicability to punching)





Reference Fig. 3 (mechanism of improved handling of film)

